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 3-29-02

PRELIMINARY AMENDMENT ACCOMPANYING APPLICATION

ATTY. DOCKET NO. 09799107-0009

SERIAL NO. 09/966861

DATE FILED: 9-28-01

INVENTION: "HIGH PURITY COBALT, METHOD OF MANUFACTURING THEREOF, AND HIGH-PURITY COBALT TARGETS"

Assistant Commissioner of Patents
Washington, D.C. 20231

S I R:

Between the title and the heading “Background of the Invention” on page 1, insert the following:

--RELATED APPLICATION DATA

The present application claims priority to Japanese Application(s) No(s). P2000-338288 filed September 29, 2000, which application(s) is/are incorporated herein by reference to the extent permitted by law.--

Respectfully submitted,

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